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Substitute for form 1449A/B/PTO			Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			Application Number	10/767,298-Conf.# 5002	
			Filing Date	January 28, 2004	
			First Named Inventor	Lingyi A. Zheng	
			Art Unit	2824-2891	
			Examiner Name	Michael K. Luhrs-	
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
CC ↑		US-11/027,825	Filed 12-29-2004	Derderian et al.	
		US-10/933,604	Filed 09-02-2004	Carpenter et al.	
		US-10/687,458	Filed 10-15-2003	Kubista et al.	
		US-10/683,424	Filed 10-10-2003	Mardian	
		US-10/839,316	Filed 05-05-2004	Saragiannis et al.	
		US-10/814,573	Filed 03-31-2004	Gealy et al.	
		US-11/043,629	Filed 01-25-2005	Rueger et al.	
		US-11/018,142	Filed 12-20-2004	Rueger et al.	
		US-10/840,571	Filed 05-06-2004	Dando et al.	
		US-10/859,883	Filed 06-02-2004	Miller et al.	
		US-10/683,606	Filed 10-09-2003	Derderian	
		US-10/733,523	Filed 10-10-2003	Beaman et al.	
		US-11/027,809	Filed 12-29-2004	Carpenter et al.	
		US-579,269	03-23-1897	Hent	
		US-3,618,919	11-09-1971	Beck	
CC ↓		US-3,620,934	11-16-1971	Endie	
		US-3,630,881	12-28-1971	Lester et al.	
		US-3,630,769	12-28-1971	Hart et al.	
CC		US-3,634,212	01-11-1972	Valayll et al.	

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CC	US-4,018,949	04-19-1977	Donokowski et al.	
↑	US-4,242,182	12-30-1980	Popescu	
	US-4,269,625	05-26-1981	Molenaar	
	US-4,289,061	09-15-1981	Emmett	
	US-4,397,753	08-09-1983	Czaja	
	US-4,438,724	03-27-1984	Doehler et al.	
	US-4,469,801	09-04-1984	Hirai et al.	
	US-4,545,136	10-08-1985	Izu et al.	
	US-4,590,042	05-20-1986	Drage	
	US-4,681,777	07-21-1987	Engelken et al.	
	US-4,826,579	05-02-1989	Westfall	
	US-4,948,979	08-14-1990	Munakata et al.	
	US-4,949,669	08-21-1990	Ishii et al.	
	US-4,966,646	10-30-1990	Zdeblick	
	US-4,977,106	12-11-1990	Smith	
	US-5,076,205	12-31-1991	Vowles et al.	
	US-5,091,207	02-25-1992	Tanaka	
	US-5,131,752	07-21-1992	Yu et al.	
	US-5,136,975	08-11-1992	Bartholomew et al.	
	US-5,172,849	12-22-1992	Barten et al.	
	US-5,200,023	04-06-1993	Gifford et al.	
	US-5,223,113	06-29-1993	Kaneko et al.	
	US-5,232,749	08-03-1993	Gilton	
	US-5,248,527	09-28-1993	Uchida et al.	
	US-5,364,219	11-15-1994	Takahashi et al.	
	US-5,377,429	01-03-1995	Sandhu et al.	
	US-5,380,396	01-10-1995	Shikida et al.	
	US-5,409,129	04-25-1995	Tsukada et al.	
	US-5,418,180	05-23-1995	Brown	
	US-5,427,666	06-27-1995	Mueller et al.	
↓	US-5,433,835	07-18-1995	Demaray et al.	
CC	US-5,445,491	08-29-1995	Nakagawa et al.	

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CC	US-5,480,818	01-02-1996	Matsumoto et al.	
	US-5,498,292	03-12-1996	Ozaki	
	US-5,500,256	03-19-1996	Watabe	
	US-5,522,934	06-04-1996	Suzuki et al.	
	US-5,536,317	07-16-1996	Crain et al.	
	US-5,562,800	10-08-1996	Kawamura	
	US-5,589,002	12-31-1996	Su	
	US-5,592,581	01-07-1997	Okase	
	US-5,595,606	01-21-1997	Fujikawa et al.	
	US-5,599,513	02-04-1997	Masaki et al.	
	US-5,624,498	04-29-1997	Lee et al.	
	US-5,626,936	05-06-1997	Alderman	
	US-5,640,751	06-24-1997	Faria	
	US-5,643,394	07-01-1997	Maydan et al.	
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	US-5,693,288	12-02-1997	Nakamura	
	US-5,729,896	03-24-1998	Dalai et al.	
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	US-5,766,364	06-16-1998	Ishida et al.	
	US-5,769,952	06-23-1998	Komino	
	US-5,788,778	08-04-1998	Shang et al.	
	US-5,792,700	08-11-1998	Tumer et al.	
	US-5,792,269	08-11-1998	Deacon et al.	
	US-5,820,641	10-13-1998	Gu et al.	
	US-5,827,370	10-27-1998	Gu	
	US-5,833,888	11-10-1998	Arya et al.	
	US-5,846,330	12-08-1998	Quirk et al.	
	US-5,846,275	12-08-1998	Lane et al.	
	US-5,851,849	12-22-1998	Comizzoli et al.	
	US-5,865,417	02-02-1999	Harris et al.	
V	US-5,879,459	03-09-1999	Gadgil et al.	
CC	US-5,895,530	04-20-1999	Shrotriya et al.	

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CC	US-5,908,947	06-01-1999	Vaartstra	
↑	US-5,932,286	08-03-1999	Beinglass et al.	
	US-5,953,634	09-14-1999	Kajita et al.	
	US-5,956,613	09-21-1999	Zhao et al.	
	US-5,968,587	10-19-1999	Frankel	
	US-5,972,430	10-26-1999	DiMeo, Jr. et al.	
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	US-5,997,588	12-07-1999	Goodwin et al.	
	US-6,008,086	12-28-1999	Schuegraf et al.	
	US-6,032,923	03-07-2000	Biegelsen et al.	
	US-6,042,652	03-28-2000	Hyun et al.	
	US-6,045,620	04-04-2000	Tepman et al.	
	US-6,059,885	05-09-2000	Ohashi et al.	
	US-6,062,256	05-16-2000	Miller et al.	
	US-6,070,551	06-06-2000	Li et al.	
	US-6,080,446	06-27-2000	Tobe et al.	
	US-6,079,426	06-27-2000	Subrahmanyam et al.	
	US-6,086,677	07-11-2000	Umotoy et al.	
	US-6,089,543	07-18-2000	Freerks	
	US-6,109,206	08-29-2000	Maydan et al.	
	US-09/651,037	08-30-2000	Mardian	
	US-6,123,107	09-26-2000	Selser et al.	
	US-6,129,331	10-10-2000	Henning et al.	
	US-6,139,700	10-31-2000	Kang et al.	
	US-6,143,659	11-07-2000	Leem	
	US-6,143,077	11-07-2000	Ikeda et al.	
	US-6,143,078	11-07-2000	Ishikawa et al.	
	US-6,144,060	11-07-2000	Park et al.	
	US-6,149,123	11-21-2000	Harris et al.	
	US-6,160,243	12-12-2000	Cozad	
↓	US-6,161,500	12-19-2000	Kopacz et al.	
CC	US-6,174,366	01-16-2001	Ihantola	

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CC	US-6,174,377	01-16-2001	Doering et al.	
A	US-6,174,809	01-16-2001	Kang et al.	
	US-6,173,673	01-16-2001	Golovato et al.	
	US-6,178,660	01-30-2001	Emmi et al.	
	US-6,182,603	02-02-2001	Shang et al.	
	US-6,192,827	02-27-2001	Welch et al.	
	US-6,194,828	02-27-2001	Pang et al.	
	US-6,193,802	02-27-2001	Pang et al.	
	US-6,197,119	03-06-2001	Dozoretz et al.	
	US-6,200,415	03-13-2001	Maraschin	
	US-6,203,613	03-20-2001	Gates et al.	
	US-6,206,972	03-27-2001	Dunham	
	US-6,211,078	04-03-2001	Matthews	
	US-6,211,033	04-03-2001	Sandhu et al.	
	US-6,210,754	04-03-2001	Lu et al.	
	US-6,214,714	04-10-2001	Wang et al.	
	US-6,237,394	05-29-2001	Harris et al.	
	US-6,237,529	05-29-2001	Spahn	
	US-6,245,192	06-12-2001	Dhindsa et al.	
	US-6,255,222	07-03-2001	Xia et al.	
	US-6,263,829	07-24-2001	Schneider et al.	
	US-2001/0010309-A1	08-02-2001	Van Bilsen	
	US-6,270,572	08-07-2001	Kim et al.	
	US-2001/0011526-A1	08-09-2001	Doering et al.	
	US-6,280,584	08-28-2001	Kumar et al.	
	US-6,287,980	09-11-2001	Hanazaki et al.	
	US-6,287,965	09-11-2001	Kang et al.	
	US-6,291,337	09-18-2001	Sidhwa	
	US-6,290,491	09-18-2001	Shahvandi et al.	
	US-2001/0024387-A1	09-27-2001	Raaijmakers et al.	
V	US-6,297,539	10-02-2001	Ma et al.	
CC	US-6,302,964	10-16-2001	Umotoy et al.	

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CC	US-6,302,965	10-16-2001	Umotoy et al.	
↑	US-6,303,953	10-16-2001	Doan et al.	
	US-2001/0029892-A1	10-18-2001	Cook et al.	
	US-6,305,314	10-23-2001	Sneh et al.	
	US-6,309,161	10-30-2001	Hofmeister	
	US-6,315,859	11-13-2001	Donohoe	
	US-2001/0045187-A1	11-29-2001	Uhlenbrock	
	US-6,329,297	12-11-2001	Balish et al.	
	US-2001/0054484-A1	12-27-2001	Komino	
	US-2002/0007790-A1	01-24-2002	Park	
	US-6,342,277	01-29-2002	Sherman	
	US-6,346,477	02-12-2002	Kaloyeros et al.	
	US-6,347,602	02-19-2002	Goto et al.	
	US-6,347,918	02-19-2002	Blahnik	
	US-2002/0020353-A1	02-21-2002	Redemann et al.	
	US-6,355,561	03-12-2002	Sandhu et al.	
	US-6,358,323	03-19-2002	Schmitt et al.	
	US-2002/0043216-A1	04-18-2002	Hwang et al.	
	US-6,374,831	04-23-2002	Chandran et al.	
	US-2002/0052097-A1	05-02-2002	Park	
	US-6,387,185	05-14-2002	Doering et al.	
	US-6,387,207	05-14-2002	Janakiraman et al.	
	US-2002/0076508-A1	06-20-2002	Chiang et al.	
	US-2002/0076490-A1	06-20-2002	Chiang et al.	
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	US-6,420,230	07-16-2002	Derderian et al.	
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	US-2002/0094689-A1	07-18-2002	Park	
↓	US-2002/0100418-A1	08-01-2002	Sandhu et al.	
CC	US-6,428,859	08-06-2002	Chiang et al.	

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CC	US-2002/0104481-A1	08-08-2002	Chiang et al.	
↑	US-6,432,831	08-13-2002	Dhindsa et al.	
	US-6,432,259	08-13-2002	Noorbaksh et al.	
	US-6,432,256	08-13-2002	Raoux	
	US-2002/0110991-A1	08-15-2002	Li	
	US-2002/0108714-A1	08-15-2002	Doering et al.	
	US-6,435,865-B1	08-20-2002	Tseng et al.	
	US-6,444,039	09-03-2002	Nguyen	
	US-2002/0127745-A1	09-12-2002	Lu et al.	
	US-6,450,117	09-17-2002	Muruges et al.	
	US-6,451,119	09-17-2002	Sneh et al.	
	US-2002/0129768-A1	09-19-2002	Carpenter et al.	
	US-6,458,416	10-01-2002	Derderian et al.	
	US-6,461,931	10-08-2002	Eldridge	
	US-6,461,436	10-08-2002	Campbell et al.	
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	US-2002/0146512-A1	10-10-2002	Rossman	
	US-2002/0164420-A1	11-07-2002	Derderian et al.	
	US-2002/0162506-A1	11-07-2002	Sneh et al.	
	US-2002/0185067-A1	12-12-2002	Upham	
	US-2002/0195201-A1	12-26-2002	Beer	
	US-2002/0197402-A1	12-26-2002	Chiang et al.	
	US-2002/0195056-A1	12-26-2002	Sandhu et al.	
	US-2003/0003730-A1	01-02-2003	Li	
	US-2003/0000473-A1	01-02-2003	Chae et al.	
	US-2003/0003697-A1	01-02-2003	Agarwal et al.	
	US-6,503,330	01-07-2003	Sneh et al.	
	US-6,506,254	01-14-2003	Bosch et al.	
	US-2003/0013320-A1	01-16-2003	Kim et al.	
	US-6,509,280	01-21-2003	Choi	
↓	US-2003/0023338-A1	01-30-2003	Chin et al.	
CC	US-2003/0024477-A1	02-06-2003	Okuda et al.	

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CC		US-2003/0027428-A1	02-06-2003	Ng et al.	
↑		US-2003/0027431-A1	02-06-2003	Sneh et al.	
		US-10/365,085	02-11-2003	Carpenter et al.	
		US-2003/0037729-A1	02-27-2003	DeDontney et al.	
		US-6,534,395	03-18-2003	Werkhoven et al.	
		US-6,534,007	03-18-2003	Blonigan et al.	
		US-2003/0060030-A1	03-27-2003	Lee et al.	
		US-6,540,838	04-01-2003	Sneh et al.	
		US-6,541,353	04-01-2003	Sandhu et al.	
		US-2003/0066483-A1	04-10-2003	Lee et al.	
		US-2003/0070618-A1	04-17-2003	Campbell et al.	
		US-2003/0070617-A1	04-17-2003	Kim et al.	
		US-2003/0070609-A1	04-17-2003	Campbell et al.	
		US-6,551,929	04-22-2003	Kori et al.	
		US-2003/0075273-A1	04-24-2003	Kilpela et al.	
		US-2003/0079686-A1	05-01-2003	Chen et al.	
		US-6,562,140	05-13-2003	Bondestam et al.	
		US-6,562,141	05-13-2003	Clarke	
		US-2003/0098372-A1	05-29-2003	Kim	
		US-2003/0098419-A1	05-29-2003	Ji et al.	
		US-6,573,184	06-03-2003	Park	
		US-2003/0106490-A1	06-12-2003	Jallepally et al.	
		US-6,579,372	06-17-2003	Park	
		US-6,579,374	06-17-2003	Bondestam et al.	
		US-2003/0121608-A1	07-03-2003	Chen et al.	
		US-6,596,085	07-22-2003	Schmitt et al.	
		US-6,602,346	08-05-2003	Gochberg	
		US-2003/0159780-A1	08-28-2003	Carpenter et al.	
		US-10/665,908	09-18-2003	Sargiannis et al.	
		US-6,630,201	10-07-2003	Chiang et al.	
↓		US-2003/0194862-A1	10-16-2003	Mardian et al.	
CC		US-2003/0192645-A1	10-16-2003	Liu	

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CC	US-6,635,965	10-21-2003	Lee et al.	
↑	US-6,638,879	10-28-2003	Hsieh et al.	
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	US-2004/0040503-A1	03-04-2004	Basceri et al.	
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	US-2004/0083961-A1	05-06-2004	Basceri	
	US-2004/0083960-A1	05-06-2004	Dando	
	US-2004/0099377-A1	05-27-2004	Newton et al.	
	US-2004/0124131-A1	07-01-2004	Aitchison et al.	
	US-2004/0154538-A1	08-12-2004	Carpenter et al.	
	US-6,818,249-B2	11-16-2004	Derderian	
	US-2004/0226507-A1	11-18-2004	Carpenter et al.	
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	US-6,838,114-B2	01-04-2005	Carpenter et al.	
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Application Number	10/767,298-Conf.# 5002
		Filing Date	January 28, 2004
		First Named Inventor	Lingyi A. Zheng
		Art Unit	2024 2891
		Examiner Name	Michael K. Luhrs
		Attorney Docket Number	108298714US
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		Filing Date	January 28, 2004
		First Named Inventor	Lingyi A. Zheng
		Art Unit	2824 2F9/
		Examiner Name	Michael K. Luhre
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		Attorney Docket Number	108298714US

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Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T*
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		Filing Date	January 28, 2004
		First Named Inventor	Lingyi A. Zheng
		Art Unit	2824-2891
		Examiner Name	Michael K. Lubers
		Attorney Docket Number	108298714US
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			Art Unit	2824-2891	
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